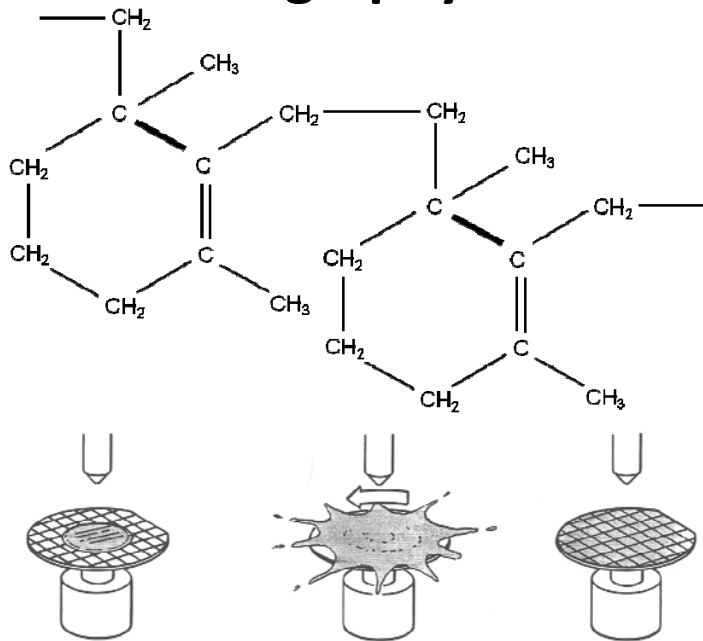
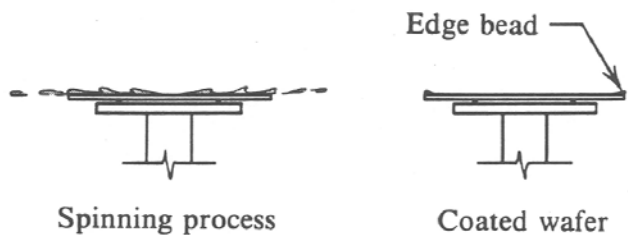


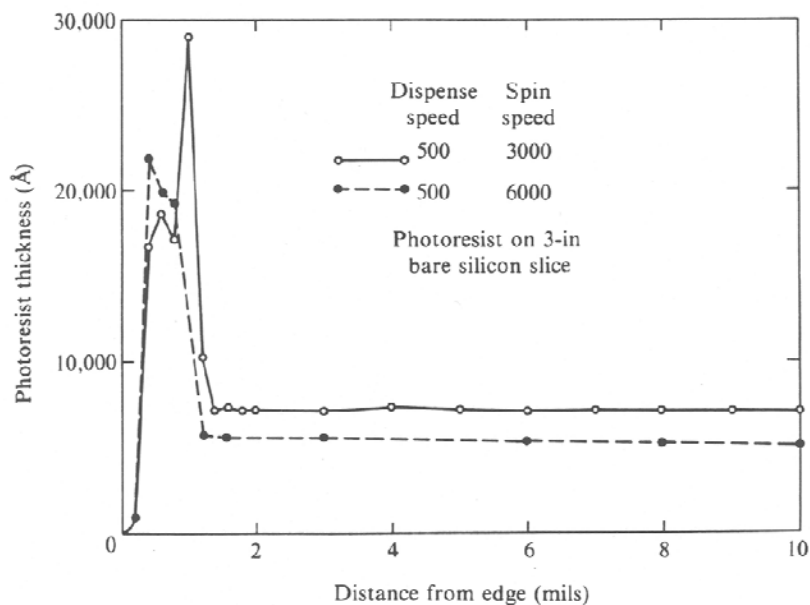
# Photolithography

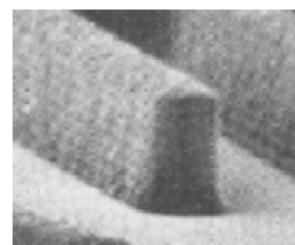
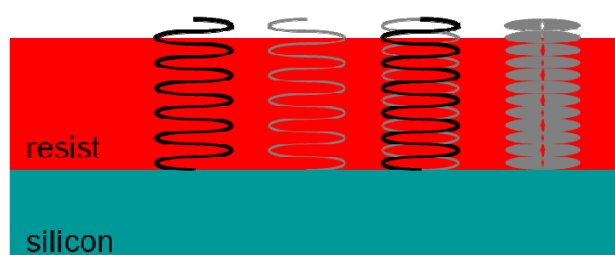
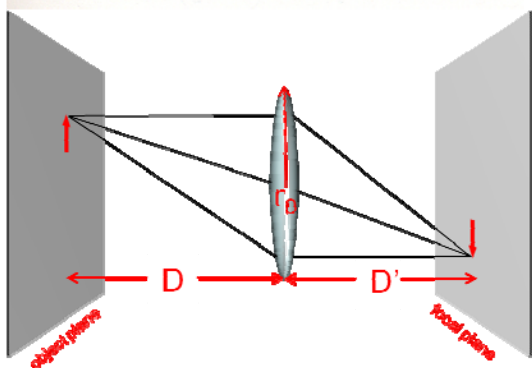
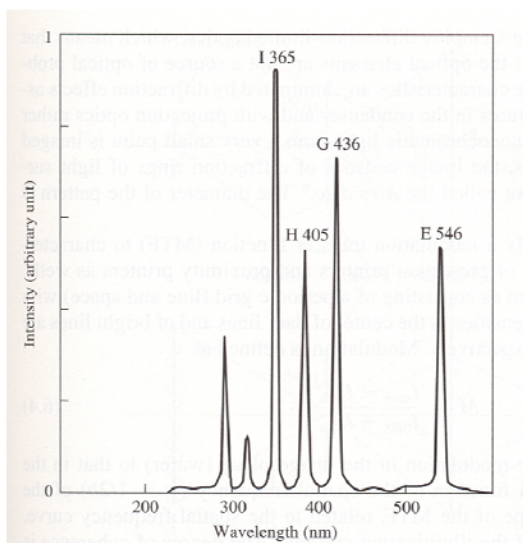
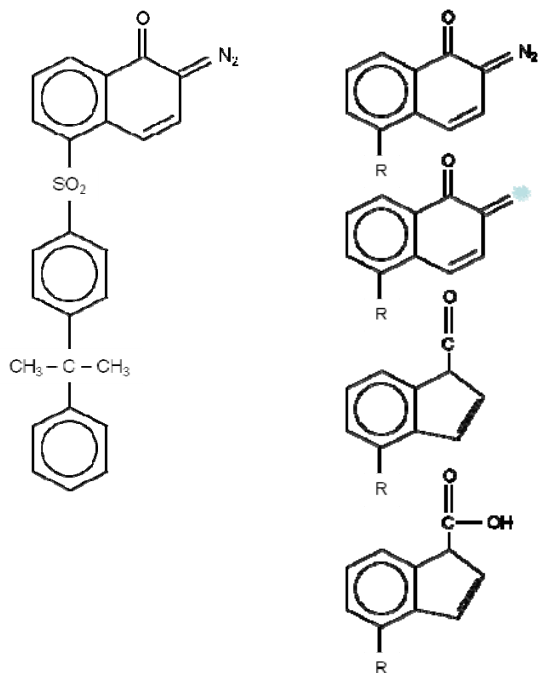


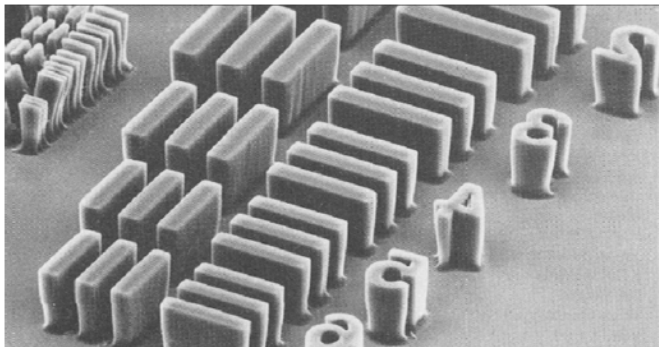
W. S. Ruska, *Microelectronic Processing*, Fig. 4-11, p. 130 (McGraw-Hill, New York, 1987)



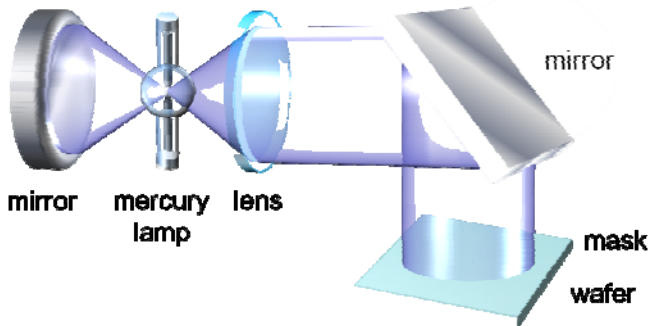
W. S. Ruska, *Microelectronic Processing*, Fig. 4-11, p. 130 (McGraw-Hill, New York, 1987)







O. Rohde, M. Reidker, S. Schaffner, and J. Behrman, *Solid State Technology*, vol. 20 no. 9 (Sept 1999) p. 110



**Contact  
Printer**

**Proximity  
Printer**

**Projection  
Printer**

